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**Certification under 37 CFR 1.8(a)**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to The Assistant Commissioner of Patents, Washington, D.C. 20231 on February 26, 2002.

Brian W. Hameder (Reg. No. 45,613)  
Name

Brian W. Hameder  
Signature

DOCKET: CU-2727

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Hideshi HATTORI

Serial No.: 10/018,718

Group Art Unit:

Filed: December 14, 2001

Examiner:

For: ANTIREFLECTION FILM AND METHOD FOR MANUFACTURING THE SAME

THE ASSISTANT COMMISSIONER FOR PATENTS  
Washington, D.C. 20231

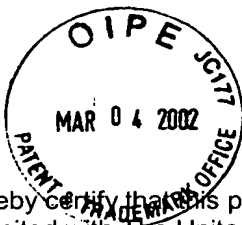
**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT WITHIN THREE MONTHS OF  
FILING OR BEFORE MAILING OF FIRST OFFICE ACTION**

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of the first Office Action on the merits, whichever event occurs last. 37 CFR 1.97(b).

Date: February 26, 2002

Brian W. Hameder  
Signature of Attorney  
Brian W. Hameder  
Ladas & Parry  
224 South Michigan Avenue  
Chicago Illinois 60604  
Tel. No. (312) 427-1300  
Reg. No. 45613

**RECEIVED**  
MAR 26 2002  
**TC 1700**



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**INFORMATION DISCLOSURE STATEMENT**

Applicants submit herewith patents, publications or other information of which the applicants are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose under 37 CFR 1.56.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

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The references submitted herein are listed on PTO-1449 form (modified) enclosed herewith. A copy of each reference listed is being furnished except any duplicate or cumulative patents or publications specified otherwise.

A translation of any foreign language reference, if any, is indicated in PTO-1449 form and being submitted herein if it is readily available. Otherwise it should be construed that such translation is not readily available.

Also submitted herein is a copy of the International search report which satisfies the requirement for a concise explanation of any non-English reference cited therein, as provided in MPEP §609 A(3).

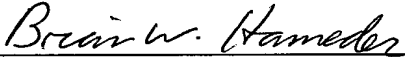
Additional comments, if any, on the relevance of each reference listed are provided as follows:

The Statement is made on the basis of the information:

<u>      </u> <u>  X  </u> <u>      </u>	supplied by the inventor(s); supplied by an individual associated with the filing and prosecution of this application (37 CFR 1.56(c)); or in the attorney's file.
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Respectfully submitted,

Date: February 26, 2002

  
\_\_\_\_\_  
Signature of Attorney  
Brian W. Hameder  
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224 South Michigan Avenue  
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FORM PTO-1449

(37 CFR 1.98(b))

ATTY. DOCKET NO.

CU-2727

SERIAL NO.

10/018,718

APPLICANT

Hideshi HATTORI

FILING DATE

December 14, 2001

GROUP

[illegible][illegible]

			<p>Katsuhiko Ariga, Yuri Lvov, Mitsuhiro Onda, Izumi Ichinose and Toyoki Kunitake, Alternately Assembled Ultrathin Film of Silica Nanoparticles and Linear Polycations, Chemistry Letters, Chemical Society of Japan, 1997, No. 2, pages 125 and 126</p> <p>Takeshi Serizawa, Hiroko Takeshita, and Mitsuru Akashi, Electric Adsorption of Polystyrene Nanospheres onto the Surface of an Ultrathin Polymer Film Prepared by Using an Alternate Adsorption Technique, Langmuir, American Chemical Society, April 1998, Vol. 14, pages 4088 and 4089</p>
EXAMINER			DATE CONSIDERED

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

(Form PTO-1449)

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